



EV550717305

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/705,371
Confirmation No. 4350
Filing Date November 10, 2003
Inventor..... Brian E. Cron
Assignee..... Micron Technology, Inc.
Group Art Unit..... 3723
Examiner A. Ojini
Attorney's Docket No. MI22-2430
Customer No. 021567
Title: Methods for Conditioning Surfaces of Polishing Pads After Chemical-Mechanical
Polishing

PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop RCE
Commissioner for Patents
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Alexandria, VA 22313-450

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AMENDMENTS